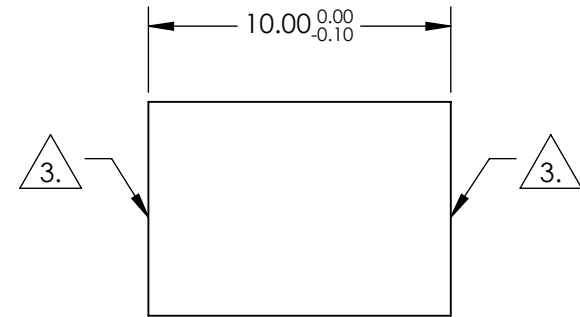
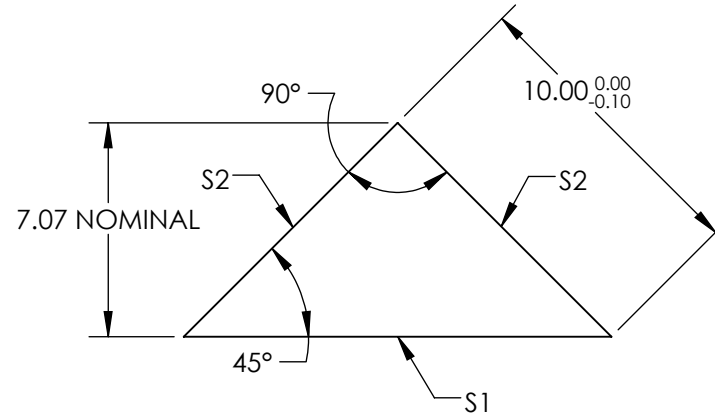
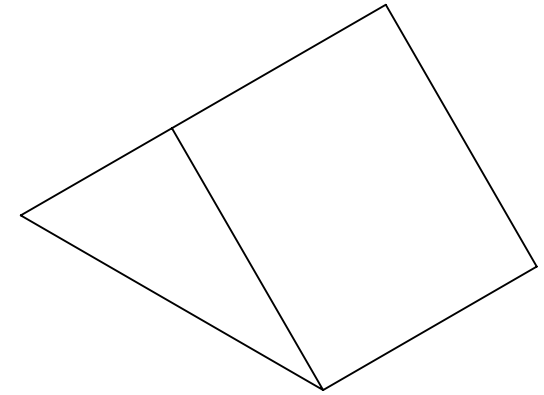


NOTES:

- 1. SUBSTRATE : FUSED SILICA
- 2. COATING (APPLY ACROSS CLEAR APERTURE)  
 S1: UNCOATED  
  
 S2: LASER V-COAT  
 R(abs) <0.25% @ 532nm  
 DAMAGE THRESHOLD :  
 PULSED: 10 J/cm<sup>2</sup> @ 20ns, 20 Hz @ 532nm

 FINE GRIND SURFACE

4. RoHS COMPLIANT

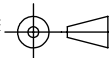


**FOR INFORMATION ONLY:  
DO NOT MANUFACTURE  
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE  
DIMENSIONS ARE FOR REFERENCE ONLY

REV. A	S1	S2
PYRAMID TOLERANCE (arcmin)	±1	±1
ANGLE TOLERANCE (arcsec)	±40	±40
SURFACE QUALITY	20-10	20-10
SURFACE FLATNESS	λ/10	λ/10
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

THIRD ANGLE PROJECTION



ALL DIMS IN

mm



TITLE	10mm, 532nm V-COAT, FUSED SILICA HIGH POWER LASER LINE RA PRISM		
DWG NO	83324	SHEET	1 OF 1